



Application No. 09/932,239

NMTI 1002-3
(747CON1)

IFW 1756-
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CERTIFICATE OF MAILING

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Kathryn Marley
Kathryn Marley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of inventor(s):

Christophe Pierrat et al.

Application No. **09/932,239**

Confirmation No. **4845**

Filing Date: **17 August 2001**

Title: **Phase Conflict Resolution for
Photolithographic Masks**

Group Art Unit: 1756

Examiner: S.R. Mohamedulla

CUSTOMER NO. 30437

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE/AMENDMENT

Sir:

In response to the Office Action mailed 30 January 2004, Applicants request the following amendments in the above-referenced application:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.

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